

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Peter J. Hopper et al.

Appln. No.: New (Div. of 10/219,896)

Filed: Herewith

For: **METHOD OF FORMING A METAL  
TRACE WITH REDUCED RF  
IMPEDANCE RESULTING FROM THE  
SKIN EFFECT (as amended)**

Group Art Unit: Unknown

Examiner: Unknown

**PRELIMINARY AMENDMENT**

**INTRODUCTORY COMMENTS**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please amend the above-identified application as follows:

**Amendments to the Specification** which begin on page 2 of this paper;

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper; and

**Remarks** which begin on page 8 of this paper.